



Docket: P910284

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**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Application of: Yang Chin Cheng

U.S. Serial No: 10/713,762

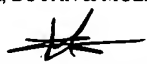
Filed: November 13, 2003

For: METHODS FOR USING A  
SILYLATION TECHNIQUE TO  
REDUCE CELL PITCH IN  
SEMICONDUCTOR DEVICES

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/ Examiner: Pham, Thanhha S.  
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/ Group Art: 2813  
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Mail Stop Non-Fee Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

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STOUT, UXA, BUYAN & MULLINS, LLP

  
Kenton R. Mullins, Reg. No. 36,331

**TRANSMITTAL**

Sir:

Submitted herewith are:

- (1) Return Receipt Postcard;
- (2) Response to Restriction Requirement;
- (3) Listing of Claims; and
- (4) Deposit Account Authorization: The Commissioner is hereby authorized to charge any needed fees to deposit account 50-1600.

Respectfully submitted,



Kenton R. Mullins  
Attorney for Applicant  
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September 23, 2005  
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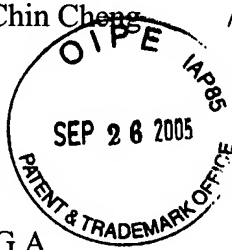
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Examiner: Pham, Thanhha S.

Group Art: 2813

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**RESPONSE TO RESTRICTION REQUIREMENT**

Sir:

Responsive to the Examiner's Office Action of August 23, 2005, Applicant hereby elects without traverse the invention of Group A-2, directed to the material layer being removed (portions) using the protectant layer as a mask wherein the material layer is selected from a group consisting of a silicon, silicon dioxide, doped silicon dioxide, silicon nitride, poly silicon, aluminum, copper, titanium, titanium nitride, tantalum and tantalum nitride, and Group B-1, directed to a silylation process being performed by a gas phase, corresponding to claims 1, 2, 4, 7-12, 17-19, 21-24, 27 and 28.

Applicant respectfully submits that the application is now in condition for a first action on the merits, and requests that such be done at an early date. Should the Examiner believe that a telephone conference with Applicant's representative would be helpful to advance the prosecution of the application, the Examiner is invited to contact the undersigned with any questions.

Respectfully submitted,

  
Kenton R. Mullins  
Attorney for Applicant  
Reg. No. 36,331

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